

## Correction to Graphene Plasmon Cavities Made with Silicon Carbide

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*ACS Omega* 2017, 2 (7), 3640–3646. DOI: [10.1021/acsomega.7b00726](https://doi.org/10.1021/acsomega.7b00726)



Cite This: *ACS Omega* 2020, 5, 30746–30746



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 Article Recommendations

The affiliation for Joshua D. Caldwell was incorrect in the original article. The corrected affiliation is given below.

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Received: October 26, 2020

Published: November 17, 2020

